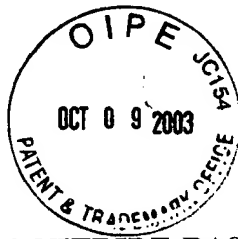


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **KANO et al.**

Serial No.: **09/941,982**

Filed: **August 30, 2001**



Group Art Unit: **2812**

Examiner: **Mulpuri, Savitri**

P.T.O. Confirmation No.: 7536

For. **METHOD OF FORMING NITRIDE-BASED SEMICONDUCTOR LAYER, AND
METHOD OF MANUFACTURING NITRIDE-BASED SEMICONDUCTOR
DEVICE**

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: October 9, 2003

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Notice of Appeal filed July 8, 2003 for two months from September 8, 2003 to November 8, 2003.

Attached please find a check in the amount of \$420.00 to cover the cost of the extension. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 50-2866. This paper is filed in triplicate.

Respectfully submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP

Stephen G. Adrian
Attorney for Applicants
Reg. No. 32,878

10/14/2003 CNEUYEN 00000110 09941982

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420.00 OP

SGA/arf

Atty. Docket No. **011083**
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